

In re Application of:

YOSHIYUKI OKADA

Application No.: 10/791,821

Filed: March 4, 2004

For: EXPOSURE APPARATUS AND

ABERRATION CORRECTION METHOD

Docket No. 00862.023502

Examiner: K. Gutierrez

Group Art Unit: 2851

July 20, 2005

MAIL STOP AMENDMENT COMMISSIONER FOR PATENTS P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED							
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	14	MINUS	20	0	x \$25 \$50	0.00	
INDEP. CLAIMS	4	MINUS	4	0	x\$100 \$200	0.00	
Fee for Multiple Dependent claims \$180/\$360							
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						0.00	

	°Verified Statement claiming small entity status is enclosed, if not filed previously.
	A check in the amount of \$ is enclosed.
	Charge \$ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06 1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.

Steven E. Warner Attorney for Applicant Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: K. Gutierrez
Yoshiyuki OKADA)	
	:	Group Art Unit: 2851
Application No.: 10/791,821)	
T'' 1 14 0004	:	
Filed: March 4, 2004)	
	:	
For: EXPOSURE APPARATUS AND)	July 20, 2005
ABERRATION CORRECTION	:	
METHOD)	

MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated May 20, 2005, please amend the above-identified application as follows: